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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TC 1700

Applicants: KATO, et al.

Serial No.: 09/767,834

Filed: January 24, 2001

For: VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR

TC 3700 MAIL ROOM

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SUPPLEMENTING INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.97 & §1.98

Assistant Commissioner of Patents
Washington, D.C. 20231

July 6, 2001

Sir:

The undersigned notes the Information Disclosure Statement submitted May 29, 2001, in connection with the above-identified application. An English-language abstract was submitted together with Japanese Patent Document No. 63-133521 enclosed with this Information Disclosure Statement.

To further facilitate consideration by the Examiner of Japanese Patent Document No. 63-133521, enclosed please find an English translation of this Japanese Patent Document No. 63-133521.

Particularly in view of the present submission of this English translation, and noting that there has not yet been a first Office Action on the merits in the above-identified application, full consideration of Japanese Patent Document No. 63-133521, upon examination of the above-identified application, is respectfully requested.

Please charge any shortage in fees due in connection with the filing of this paper to the Deposit Account No. 01-2135

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(Case No. 503.30414V27) and please credit any excess fees to such Deposit Account.

Respectfully submitted,

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